

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor: Chung J. Lee

Appln. No.: Unknown

Filed: Herewith

Title: LOW DIELECTRIC CONSTANT MATERIALS
PREPARED FROM PHOTON OR PLASMA
ASSISTED CHEMICAL VAPOR DEPOSITION
AND TRANSPORT POLYMERIZATION OF
SELECTED COMPOUNDS

PATENT APPLICATION

Art Unit: 1773

Examiner: Nakarani, Dhirajlal S.

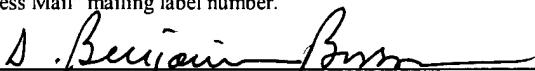
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 (Signature)
D. Benjamin Borson, Reg. No. 42,349
Signature Date: December 1, 2003

PRELIMINARY AMENDMENT

Mail Stop PATENT APPLICATION

P.O. Box 1450

Commissioner for Patents

Alexandria, VA 22313-1450

Sir:

This PRELIMINARY AMENDMENT is filed in conjunction with a Continuation Application filed under 37 C.F.R. 1.53(b).

Amendments

Please amend the above-identified application as follows:

In the Title:

Please replace the title with the new title shown below:

FLUORINATED AROMATIC PRECURSORS